

ThEtching is a novel etching system for live viewing of etching processes on materialographic samples: The user is thus able to observe his finished prepared sample during the etching process and he can record the microstructure either with individual photos or a video sequence.

The advantages are:

- continuous observation during the complete etching process
- manual / automatic etching
- retrieval of programmed etching recipes possible
- own etching parameters storable
- low etchant consumption
- clean and save work



Etchant: 100ml dest. H2O + 3q potassium metabisulfite - Material: GJS with a laser weld - Magnification: 50: 1

Other systems are under development:

The tching EL a system for etching under a specific current voltage (electrolytic etching) The tching Therm a system for etching at different temperatures



